Technical Datasheet 520

optoSiC+ XY20G

ultra-high performance 20mm aperture generic scanning mirrors

optoSiC[®] XY20G generic scanning mirrors are designed using optoSiC GmbH's protected spine and rib structure as a one-size-fits-all approach for either left- or right-handed laser scanning systems using a symmetrical Y (or second) mirror at <20.0mm aperture.

These mirrors are manufactured from optoSiC+ grade Silicon Carbide to give optimum stiffness, dynamic flatness and high resonant frequencies under high torque loadings while offering very low Moment of Inertia for all scanning applications where processing speed and performance is paramount.

optoSiC[®] XY20G generic scanning mirrors are available polished at either 1/4, or 1/8 λ PV @632.8nm flatness* and either coated with UltraMAX R for CO₂, opto-1064 R for 1064nm Nd:YAG, opto-HR Visible 390-710nm, opto-532 R for 532nm, opto-355 R for 355nm or Dualband opto-1064/532 R for 1064/532nm.

Density Flexural Strength Compressive Strength Young's Modulus [E] Poisson's Ratio Surface Roughness CTE	>3.16g/cm ³ 510 Mpa (DIN EN 843-1) 2200 MPa 420 Gpa (DIN EN 843-2) 0.17 n Ra. \geq 0.3273nm (pre-coated) 4.1 α [10 ⁻⁶ /°K] 20-500°C (DIN EN 821-1)		
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	Х	Y	
Mass (g)**	5.022	6.755	
Moment of Inertia (g*cm.2)**	3.097	3.097	
Resonant Frequency (kHz)**	12.987	5.049	(1 st bending)
	18.938	12.745	(1 st twisting)
Dynamic Flatness (λ)**	<1/43	<1/21	0
	$(at \ \lambda = 632.8 nm \ per \ 10,000 \ rad/sec^2)$		
Central Angle of Incidence (°)	45	37.5	
X-Y Separation	24.0mm		
X-Tilt	-15°		
Mechanical Scan Angle	$\pm 10^{\circ}$		
Aperture	20.0mm full beam (collimated)		

optoSiC+ XY20G Generic Scanning Mirror Specifications:

*Over 90% of the reflective surface from the centre point

**Modelled using CATIA, Patran and ANSYS softwares





